



Image Rce 12825 \$

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

**MAIL STOP RCE**

Satoshi TANAKO

Group Art Unit: 2825

Application No.: 09/819,690

Examiner: G. Lee

Filed: March 29, 2001

Docket No.: 109107

For: SEMICONDUCTOR, MANUFACTURING METHOD, SUBSTRATE PROCESSING  
METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

☒ Applicant further requests entry and consideration of the submission filed  
October 3, 2003.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper  
under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 149823 in the amount of ☒ \$770.00 as payment of the fees  
set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees  
or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two  
duplicate copies of this page are enclosed.

Respectfully submitted,

*Phillip D. Mancini*

James A. Oliff  
Registration No. 27,075

Phillip D. Mancini  
Registration No. 46,743

01/06/2004 JADD01 00000105 09819690  
01 FC:1801 770.00 DP

JAO:PDM/ccs

Date: January 5, 2004

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**DEPOSIT ACCOUNT USE  
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Please grant any extension  
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